IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s): Zhang et al.

Patent No.: 7,128,842 B1

Issued: October 31, 2006

For: POLYIMIDE AS A MASK IN VAPOR

HYDROGEN FLUORIDE ETCHING

Attorney Docket No.: 2269-7144.2US

VIA ELECTRONIC FILING

September 5, 2007

REQUEST FOR CERTIFICATE OF CORRECTION OF PATENT FOR APPLICANTS' MISTAKES (37 C.F.R. § 1.323)

Attn.: Certificate of Corrections Branch Commissioner for Patents P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

It is noted that Applicant(s) error appears in this patent of a typographical nature or character and correction thereof does not involve such changes in the patent as would constitute new matter or would require reexamination. A certificate of correction in the form attached hereto is requested.

Please send the Certificate to:

Name:

Joseph A. Walkowski

Address:

TraskBritt

P.O. Box 2550

Salt Lake City, Utah 84110

The Commissioner is authorized to charge \$100.00 to the TraskBritt Deposit Account No. 20-1469 for the fee as required by 37 C.F.R. § 1.20(a).

Attached hereto is Form PTO/SB/44, which is suitable for printing.

Respectfully submitted,

Joseph A. Walkowski Registration No. 28,765 Attorney for Applicant(s)

TRASKBRITT P.O. Box 2550

Salt Lake City, Utah 84110-2550

Telephone: 801-532-1922

Date: September 5, 2007

JAW/csw

Attachment: PTO/SB/44

Document in ProLaw

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(Also Form PTO-1050)

UNITED STATES PATENT AND TRADEMARK OFFICE CERTIFICATE OF CORRECTION

PATENT NO : 7,128,842 B1 Page 1 of 1

APPLICATION NO.: 09/722,400

ISSUE DATE : October 31, 2006

INVENTOR(S) : Tianhong Zhang and John K. Lee

It is certified that an error appears or errors appear in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

On the title page:

In section (73) titled Assignee: change "Micron Technology, Inc." to

--Micron Technology, Inc., Boise, ID (US)--

MAILING ADDRESS OF SENDER (Please do not use customer number below):

Joseph A. Walkowski TRASKBRITT 230 South 500 East, Suite 300 Salt Lake City, Utah 84102 USA

This collection of information is required by 37 CFR 1.322, 1.323, and 1.324. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 1.0 hour to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Attention Certificate of Corrections Branch, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.